

Notice of References Cited

Application/Control No.

09/810,333

Applicant(s)/Patent Under
Reexamination
BEHIN ET AL.

Examiner

Tamai IE Karl

Art Unit

2834

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5959760 ✓	09-1999	Yamada et al.	359/224
	B	US-6000280	12-1999	Miller et al.	73/105
	C	US-6253612 ✓	07-2001	Lemkin et al.	73/504.02
	D	US-2002/000597976	01-2002	Behin et al.	359/254
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	04-343318 ✓	11-1992	Japan	Nakagawa et al.	G02B026/10
	O	0715981 ✓	07-1995	Japan	Nakagawa et al.	H02N001/00
	P	05-076186 ✓	05-1995	Japan	Nakagawa et al.	H02N001/00
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	Xie et al., "A CMOS Z-Axis Capacitive Accelerometer with Comb Finger Sensing", The 13th Annual International Micro Electro Mechanical Systems Conference (Miyazaki, Japan), Jan 23-27, 2000, pp. 496-501. ✓				
	V	Translation of JP 4-343318, 11/1992 ✓				
	W	Translation of JP 5-076186, 3/1993 ✓				
	X					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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